



ITW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/614,345

Confirmation No.: 7853

In re Application of

Masaaki KURIHARA et al.

Group Art Unit: 1756

Filed: July 8, 2003

Examiner: Unassigned

For: PHASE MASK FOR FORMING DIFFRACTION GRATING, METHOD OF
FABRICATING PHASE MASK AND METHOD FOR FORMING DIFFRACTION GRATING

STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It would be appreciated if you would indicate the status of
the above-identified application below, including an indication as
to when the next communication can be expected, and return this
sheet to the undersigned.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

Roger W. Parkhurst
Registration No. 25,177
Robert N. Wieland
Registration No. 40,225

March 28, 2005
Date

Attorney Docket No. DAIN:740
PARKHURST & WENDEL, L.L.P.
1421 Prince Street, Suite 210
Alexandria, VA 22314-2805
Telephone: (703) 739-0220*
Facsimile: (703) 739-0229*

* Telephone or facsimile responses to Status Inquiries should be
directed to the Docket Clerk.